

RECEIVED
CENTRAL FAX CENTER

DOCKET NO. SC13151TP

NOV 28 2005

UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S) Toni D. Van Gompel et al. GROUP ART UNIT: 2812
APPLN. NO.: 10/737,115 EXAMINER: Scott B. Geyer
FILED: December 16, 2003
TITLE: METHOD FOR ELIMINATION OF EXCESSIVE FIELD OXIDE
RECESS FOR THIN SI SOI (as amended)

Certificate of Transmission under 37 CFR 1.8

I hereby certify that this correspondence is being facsimile
transmitted to the Patent and Trademark Office.

on 11/28/05

Michael Balconi-Lamica
Signature

Michael Balconi-Lamica
Printed Name of Person Signing Certificate

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated June 27, 2005, and Examiner's comments with regard thereto, please enter the following response in the above-entitled application. A petition for a two-month extension of time to respond is submitted herewith. This response is being timely filed on a Monday, November 28, 2005, within the two-month extension of time to respond, given that November 27, 2005 occurred on a Sunday.

Amendment to the Title begins on page 2 of this paper.

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims begin on page 5 of this paper.

Remarks begin on page 9 of this paper.

Amendment to the Title:

Kindly replace the present title with the following amended title:

METHOD ~~AND APPARATUS~~ FOR ELIMINATION OF EXCESSIVE FIELD OXIDE
RECESS FOR THIN SI SOI